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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

S. TAKECHI et al.

Art Unit: 1752

Serial No. 10/024,373

Examiner: R.E. Ashton

Filed: December 21, 2001

Attorney Docket No.: 108077-00001

For: RADIATION SENSITIVE MATERIAL AND METHOD FOR FORMING PATTERN

AMENDMENT UNDER 37 C.F.R. §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 29, 2003

Sir:

This paper is filed in response to the Office Action dated September 29, 2003, in connection with the above-identified patent application. Applicants respectfully request entry of the following amendments without prejudice.